



4329.2566

RVO/LSD

PLEASE STAMP TO ACKNOWLEDGE RECEIPT OF THE FOLLOWING:

New U.S. Application for:

FILM FORMATION METHOD, SEMICONDUCTOR ELEMENT AND METHOD THEREOF, AND METHOD OF MANUFACTURING A DISK-SHAPED STORAGE MEDIUM

Inventors: Shinichi ITO and Katsuya OKUMURA

BOX PATENT APPLICATION

1. Check for \$804.00
2. Transmittal Letter
3. Application - 61 pages, including 1 independent claim and 23 claims total.
4. Drawings - 11 sheets of formal drawings containing 28 figures.
5. Declaration and Power of Attorney.
6. Recordation Form Cover Sheet and Assignment to Kabushiki Kaisha Toshiba.
7. Certified copy of Japanese Application No. 2000-127953, filed April 27, 2000.
8. Certified copy of Japanese Application No. 2000-311124, filed October 11, 2000.
9. Information Disclosure Statement and Information Disclosure Citation, PTO 1449 with 7 documents attached.

Dated: April 26, 2001

CASE REF: 04329.2566

(Due Date: 04/27/01)

CUSTOMER NUMBER: 22,852

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